



Attorney Docket No: TSMC2003-0782
[N1280-00285]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Jhon Jhy Liaw

Confirmation No.: 5620

Serial No.: 10/823,822

Group Art Unit: 1756

Filed: April 15, 2004

Examiner: Not Yet Assigned

For: **METHOD FOR USING ASYMMETRIC OPC STRUCTURES ON LINE ENDS OF SEMICONDUCTOR PATTERN LAYERS**

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